

Notice of References Cited

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10/643,063

Applicant(s)/Patent Under
Reexamination
CHOI ET AL.

Examiner

Dung Nguyen

Art Unit

2871

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0046027	11-2001	TAI et al.	349/159
	B	US-			
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